

1 Article

2 **Modeling and Analysis of Opto-Fluidic Sensor for** 3 **Lab-On- a-Chip Application**

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8 Abstract: In this work modeling and analysis of an integrated opto-fluidic sensor, with a focus on
9 achievement of single mode optical confinement and continuous flow of micro particles in the
10 microfluidic channel for Lab-on-a Chip (LOC) sensing application is presented. This sensor consists
11 of integrated optical waveguides, microfluidic channel among other integrated optical
12 components. A continuous flow of micro particles in a narrow fluidic channel is achieved by
13 maintaining the two sealed chambers at different temperatures and by maintaining a constant
14 pressure of 1Pa at the centroid of narrow fluidic channel geometry. The analysis of silicon on
15 insulator (SOI) integrated optical waveguide at an infrared wavelength of 1550nm for single mode
16 sensing operation is presented. The optical loss is found to be 0.0005719dB/cm with an effective
17 index of 2.2963. The model presented in this work can be effectively used to detect the nature of
18 micro particles and continuous monitoring of pathological parameters for sensing applications.

19 Keywords: micro fluidic channel; micro particles; fluid flow rate; lab-on-a-chip; waveguide
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21 **1. Introduction**

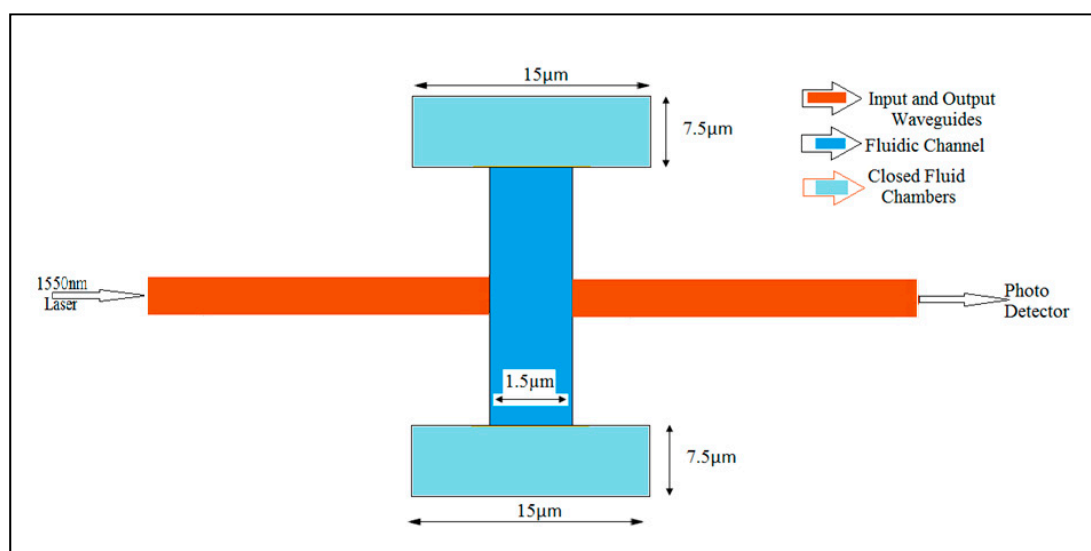
22 A Lab-On-a-Chip (LOC) is a device that integrates many laboratory tests on a common
23 integrated circuit. The size of LOC is in the range of few millimeters to few square centimeters [1].
24 LOC's requires the combination of microfluidics, manipulation and study of micro liters of fluids
25 and light-fluid interaction. Most of the LOC fabrication processes were developed on silicon. Silicon
26 fabrication processes are directly derived from semiconductor fabrication. The demands for cheap
27 and easy production of LOC's results in a simple technology for the development of
28 polydimethylsiloxane (PDMS), microfluidic devices [2]. LOC's provides application related
29 advantages such as low fluid volume consumption, faster analysis, quick response times and
30 compactness of the system due to the integration of multiple functions [3].

31 In most of the opto-fluidic sensors used in LOC applications, the sensitivity and accurate test
32 results depends on microfluidics, light-fluid interaction and light guiding properties of optical
33 waveguide. Microfluidics involves behavior, control and manipulation of fluids that are
34 geometrically constrained to a millimeter scale. At small scales (channel size around 100nm to
35 500 μ m), the comparison between effects of the momentum of a fluid to that of viscosity is given by
36 Reynolds number and its value can become very low. At lower Reynolds number, fluid flow
37 becomes laminar and molecular transportation occurs due to diffusion [4]. Accurate specifications
38 in chemical and physical properties such as temperature, concentration and pressure results in more
39 uniform reaction conditions and more accurate single or multi step reactions [5,6]. In this article the
40 optical waveguides and microfluidic channel are developed by using silicon as guiding medium.
41 Silicon is transparent to infrared light with wavelengths above 1100nm [7]. In the development of
42 biosensors, the bio-sample flow rate plays a very important role in its sensitivity. The sensitivity of
43 ultrasensitive and selective non-enzyme using copper wires is found to be high at near infrared
44 region [8]. Electrochemical detection of glucose from whole blood using copper wires [9], radio

45 frequency [10], and capillary based ring resonators [11] is presented with many other sensing
46 mechanisms [12-17].

47 Figure 1 shows schematic of an integrated opto-fluidic biosensor employed for modeling and
48 simulation. It consists of a laser source at 1550nm, photo detector and SOI input and output
49 waveguides (shown in Red color) with a narrow fluidic channel (Shown in blue color). In the
50 operation, the optical power is coupled into the input waveguide by using laser source (1550nm).
51 The guided modes propagate through the input waveguide and couples into the fluidic sensing
52 region. When the light couples from input waveguide to the output waveguide through the fluidic
53 sample the absorption of optical power occurs due to the properties of the micro particles present in
54 the fluidic sample. Based on the fluidic gap distance, a mode mismatch occurs between fluidic gap
55 and input waveguide. Mode mismatch occurs due to the absorption of optical power [18], in fluidic
56 gap. Hence mode mismatch which occurs during propagation of light through sensing region
57 (fluidic gap distance) and absorption of optical power by the analyte is used for the purpose of
58 analysis and also as a designing tool

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75 Figure 1: Schematic representation Integrated Biosensor

76 In this article modelling of micro fluidic channel to achieve a continuous flow rate between two
77 sealed chambers maintained at different temperatures and pressure acting on the fluidic channel
78 walls is described in section two. The modelling and modal analysis of SOI waveguides for use in
79 light propagation is discussed in section three. The optical properties of SOI waveguide at infrared
80 wavelength range 1500nm to 1600nm and power coupling analysis is depicted in section four.

81 2. Modeling of Micro Fluidic Channel

82 In this section microfluidic structure shown by blue color in Figure 1 is designed and analyzed.
83 Micro fluidic channels are small dimension structures developed to achieve flow rate, sorting and
84 manipulation of fluids that are geometrically constrained.

85 Figure 2 shows the structure of micro fluidic channel used for analyzing the flow rate between
86 the two closed fluidic chambers, which are maintained at different temperatures. It consists of two
87 fluidic chambers having dimensions of 7.5μm in length and 15μm in depth. The fluidic chambers are
88 linked by a narrow channel having 1.5μm width and 15μm in length. The chamber and channel
89 walls are modeled using silicon as material having a thickness of 1μm. The walls of the two
90 chambers are in thermal contact with heat sinks maintained at 290 K and 300 K, respectively. The

91 channel walls are thermally insulated. The fluid in the center of the channel is maintained at a
92 pressure of 1 Pascal.

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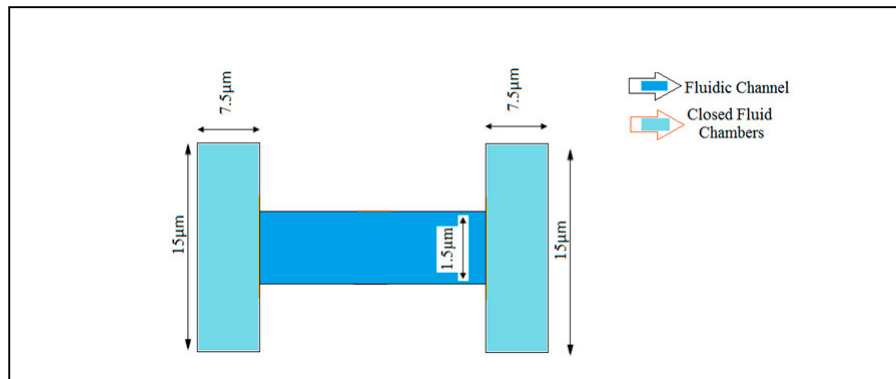
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Figure 2: Structure of micro fluidic channel

105 The micro fluidic channel shown in figure 2 is used to compute the flow between two sealed
106 chambers (closed fluid chambers) connected by a micro-channel with conducting walls when the
107 chambers are maintained at different temperatures. The material used for the walls is Silicon. To
108 achieve a continuous flow rate between two sealed chambers a birefringent object is used with a
109 pressure point at the centroid of channel geometry. For channels of micron scale dimensions the
110 Knudsen number becomes larger than 0.01. At atmospheric pressure, it is therefore necessary to use
111 a slip condition on the surfaces of walls in the vicinity of the channel. The slip velocity, u_{slip} , along
112 the walls of the micro fluidic channel is given by equations (1) and (2) [19].

$$113 \quad u_{slip} = \sigma_s \frac{\lambda}{\mu} \left(\mathbf{m} - \left(\mathbf{n}^T \mathbf{m} \right) \mathbf{n} \right) + \sigma_T \frac{\mu}{\rho T_F} \left[\nabla T_W - \left(\mathbf{n} \cdot \nabla T_W \right) \mathbf{n} \right] \quad (1)$$

$$114 \quad T_W = T_F - \zeta_T \lambda \mathbf{n} \cdot \nabla T \quad (2)$$

115 Where, λ is the mean free path of the fluid, \mathbf{n} is the boundary normal, $\boldsymbol{\tau}$ is the viscous stress
116 tensor, T_W is the wall temperature, T_F is the temperature of the fluid, μ is its viscosity, and ρ is
117 its density. The slip coefficients, σ_s is the viscous slip coefficient, σ_T is the thermal slip coefficient,
118 and ζ_T is the temperature jump coefficient can be defined by material properties, a_v is the
119 tangential momentum accommodation coefficient. The slip coefficients are given by equation (3), (4)
120 and (5) [20].

$$121 \quad \sigma_s = \frac{2 - a_v}{a_v} \quad (3)$$

$$122 \quad \sigma_T = \frac{3}{4} \quad (4)$$

$$123 \quad \zeta_T = 2 \frac{2 - a_v}{a_v} \frac{\gamma}{\gamma + 1} \frac{\kappa}{\mu C_p} \quad (5)$$

124 Where κ the thermal conductivity of fluid and the mean free path can be computed from the
125 fluid properties using the following equation (6) and (7) [21].

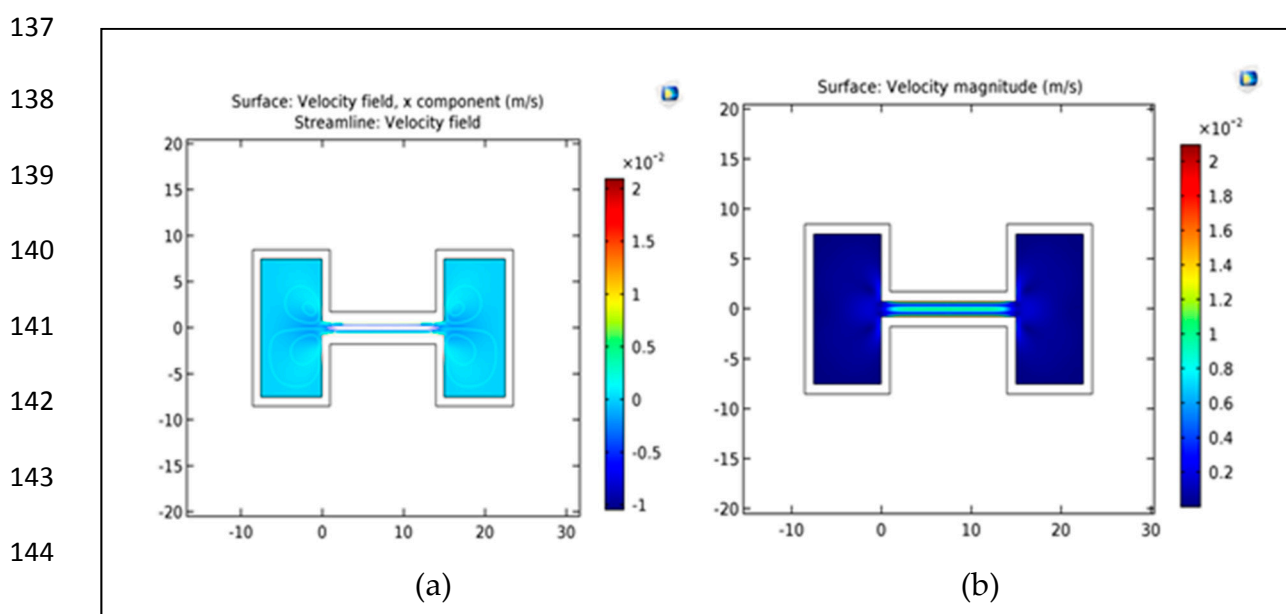
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$$127 \quad \lambda = \frac{l}{C_O} \frac{\mu}{\rho \langle c \rangle} \quad (6)$$

$$128 \quad \langle c \rangle = \sqrt{\left(\frac{8RT}{\pi M_n} \right)} = \sqrt{\frac{8p}{\pi \rho}} \quad (7)$$

129 A continuous flow between the two sealed chambers maintained at slightly different
 130 temperatures is achieved by maintaining a pressure of 1 pa at the centroid of micro fluidic geometry.
 131 The channel width is 1.5 μ m, so the Knudsen number varies from 0.064 and 0.045.

132 The relative pressure acting on the channel wall, as a function of position along the wall is
 133 represented by mean path of micro particles. As the absolute pressure in a fluid flow is reduced, the
 134 mean free path of the fluid molecules begins to approach the size of the vessel through, which, the
 135 flow occurs. The detailed analysis of the velocity magnitude, Pressure and temperature analysis is
 136 described in this section.



146 Figure 3: (a) Streamline velocity field v/s Channel length (b) Velocity Magnitude v/s Channel length

147 Figure 3 (a), shows a graph of streamline velocity field with respect to channel length. Figure 3
 148 (b) shows a graph of velocity magnitude with respect to channel length. In the steady state there is
 149 no net flow through the channel, but a flow parallel to the walls, in the direction of the thermal
 150 gradient (cold to hot), develops due to thermal creep. In order to compensate for this flow, a back
 151 flow develops in the center of the channel, which is driven by a pressure gradient in the fluid. It
 152 results in a continuous flow of fluidic sample in the narrow micro fluidic channel. This is achieved
 153 by maintaining a constant pressure of 1 Pascal at the center of fluidic channel.

154 Figure 4 (a), shows fluid mean free path. Such rarefied flows are characterized by a parameter
 155 known as the Knudsen number, which is the ratio of the mean free path to the characteristic length
 156 of the geometry. Figure 4 (b), shows the relative pressure acting on the channel wall, as a function of
 157 position along the wall.

158 Figure 5 (a) and figure 5 (b) shows the temperature and pressure contours within the model. A
 159 temperature jump occurs between the vessel walls and the fluid normal heat fluxes occur into the
 160 wall from the fluid sample.

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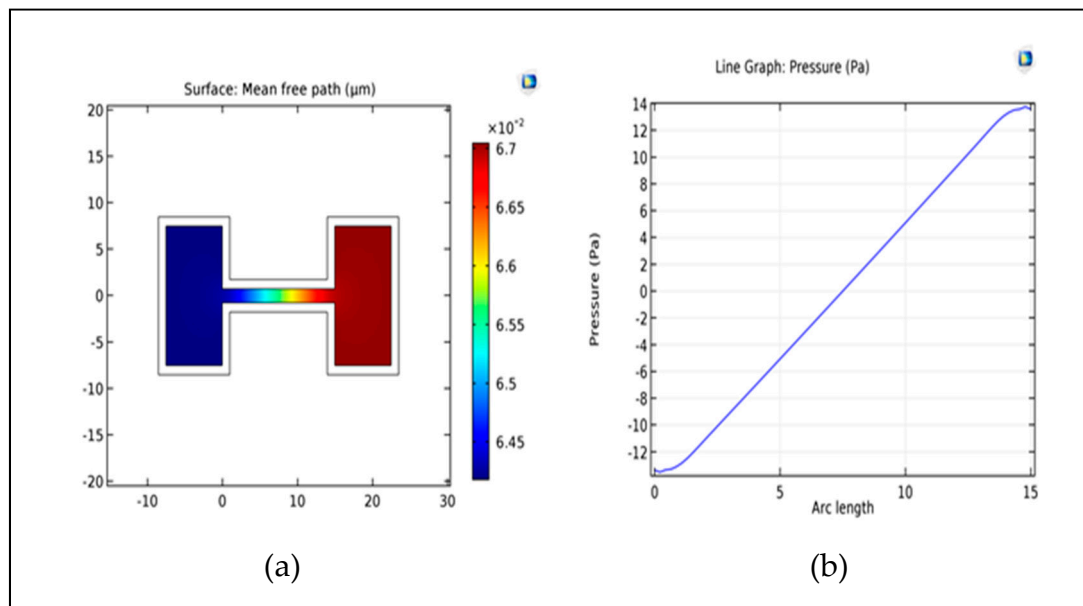
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Figure 4: (a) Mean free path v/s Channel length (b) Pressure along channel length v/s Arc length

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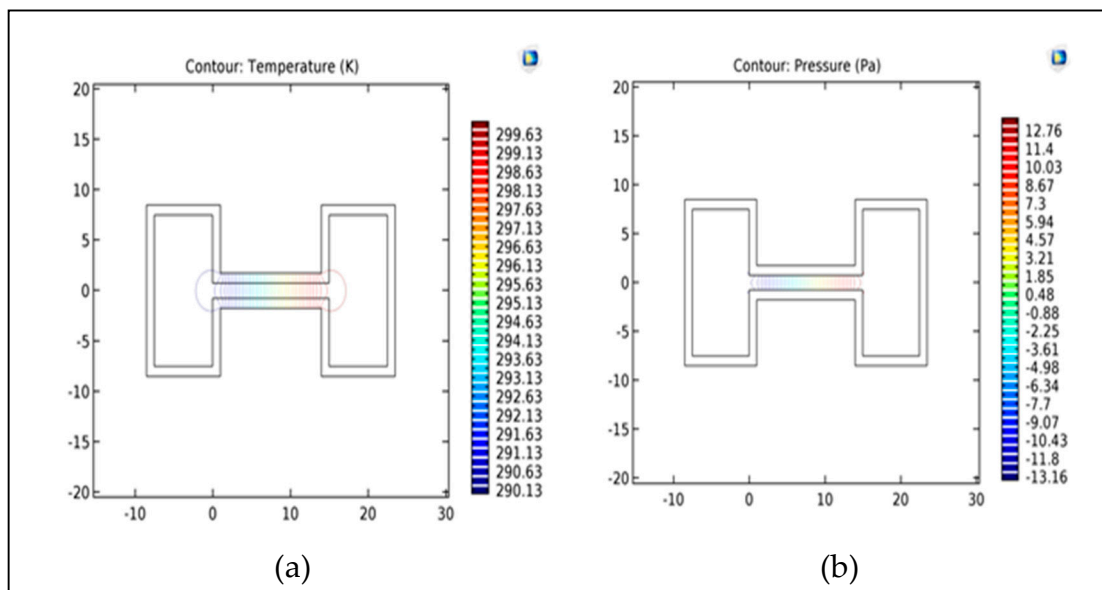
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Figure 5: Contour diagram of (a) Temperature v/s Channel length (b) Pressure v/s Channel length

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3. Modeling of SOI waveguide

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In this section, the design and modal analysis of a single mode SOI waveguide structure to operate at a wavelength of 1550nm is presented. The SOI waveguide is designed at infrared region of light spectrum (1500nm-1600nm) for single mode operation.

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Figure 6(a) shows the geometrical details of a SOI waveguide. It consists of silicon core having dimensions of 500nm width and 250nm height. These dimensions results in single mode operation. The substrate is silicon-di-oxide (SiO_2), which acts as lower cladding layer for the waveguide. The substrate height is designed for $2\mu\text{m}$ and width is designed for $4\mu\text{m}$.

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The dimensions and refractive index of the materials used in the waveguide geometry is shown in table1.

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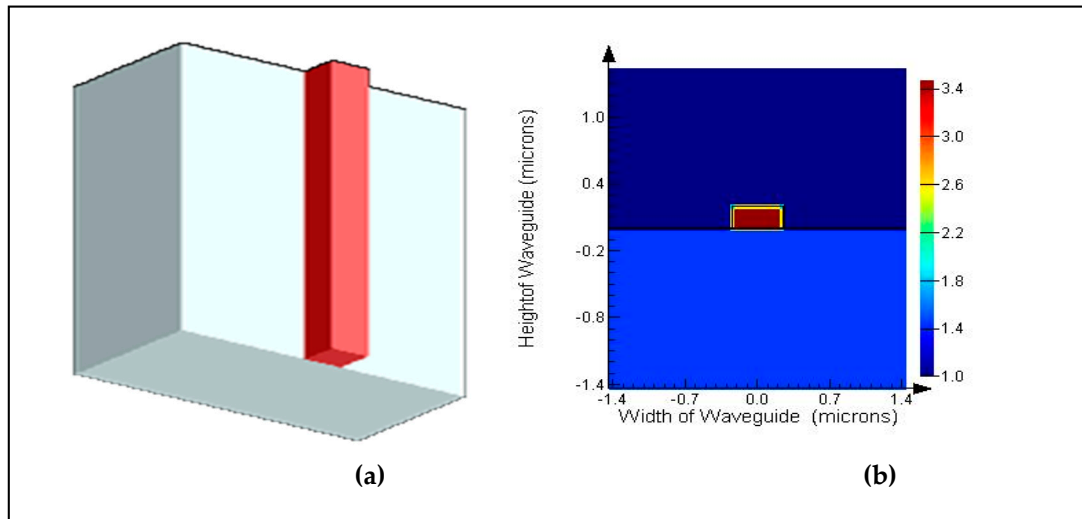
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Figure 6: (a) Waveguide geometry (b) Refractive index distribution

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Table 1: Materials and dimensions of waveguide

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Material	Width (nm)	Height (nm)	Refractive Index at 1550nm
Si (Core)	500	250	3.4714
SiO ₂ (Substrate)	4000	2000	1.55

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Figure 6 (b) shows the refractive index distribution of SOI waveguide (substrate (SiO₂), Core (Silicon) and Cover layer (Air)) at 1550nm.. There is a high refractive index contrast between silicon core (3.3714) and oxide substrate (1.55) index as well as cover layer (air) index. This high refractive index contrast results in SOI waveguides being highly amenable to light guiding at infrared wavelength. This results in excellent propagation characteristics such as dispersion, loss, effective index. The light confinement for various wavelengths in the range 1500nm to 1600nm is depicted in figure 7. It is observed that for all these wavelength range single mode operation is achieved with almost negligible loss.

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Eigen mode (EM) solver is used for numerically simulate the waveguide geometry which is shown in figure. 6(a). The simulation settings used in the EM solver is shown in Table 2. Perfectly matched layers (PML) boundary conditions are used in the simulation [13].

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Table 2: Eigen Mode Solver Settings

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Parameter	Value
Mesh Resolution	50×50
Wavelength	1550nm-1600nm
Boundary conditions	PML
Background index	1 (Air)

225 4. Results and Discussion

226 In this section, the modal and power coupling analysis of opto fluidic sensor shown in figure 1
 227 is presented. The sensor is designed to operate at 1550nm. It is observed that for 1500nm to 1600nm
 228 wavelength range single mode operation is achieved with excellent optical parameters and light
 229 confinement in input and output waveguides.

230 Figure 7 shows the optical mode confinement in SOI waveguide at 1550nm, 1530nm, 1550nm and
 231 1600nm respectively. It is evident that the optical confinement of light is pronounced at the core of
 232 the waveguide (red color) when compared to the optical power leakage into the cladding (yellowish
 233 green color). Single mode operation is achieved for a core height of 250nm for the wavelength range
 234 1500nm to 1600nm. In operation for bio-sensing application 1550nm is selected for the analysis.
 235 Figure 8 shows the magnetic field (H-field) intensity of SOI waveguide which is confined within the
 236 core region of waveguide. With the help of Figure 8, mode field diameter (MFD) is found out to be
 237 $1.774\mu\text{m}$ for a width of $0.5\mu\text{m}$. Since MFD and width of the waveguide are of similar dimensions
 238 indicating very good optical mode confinement.

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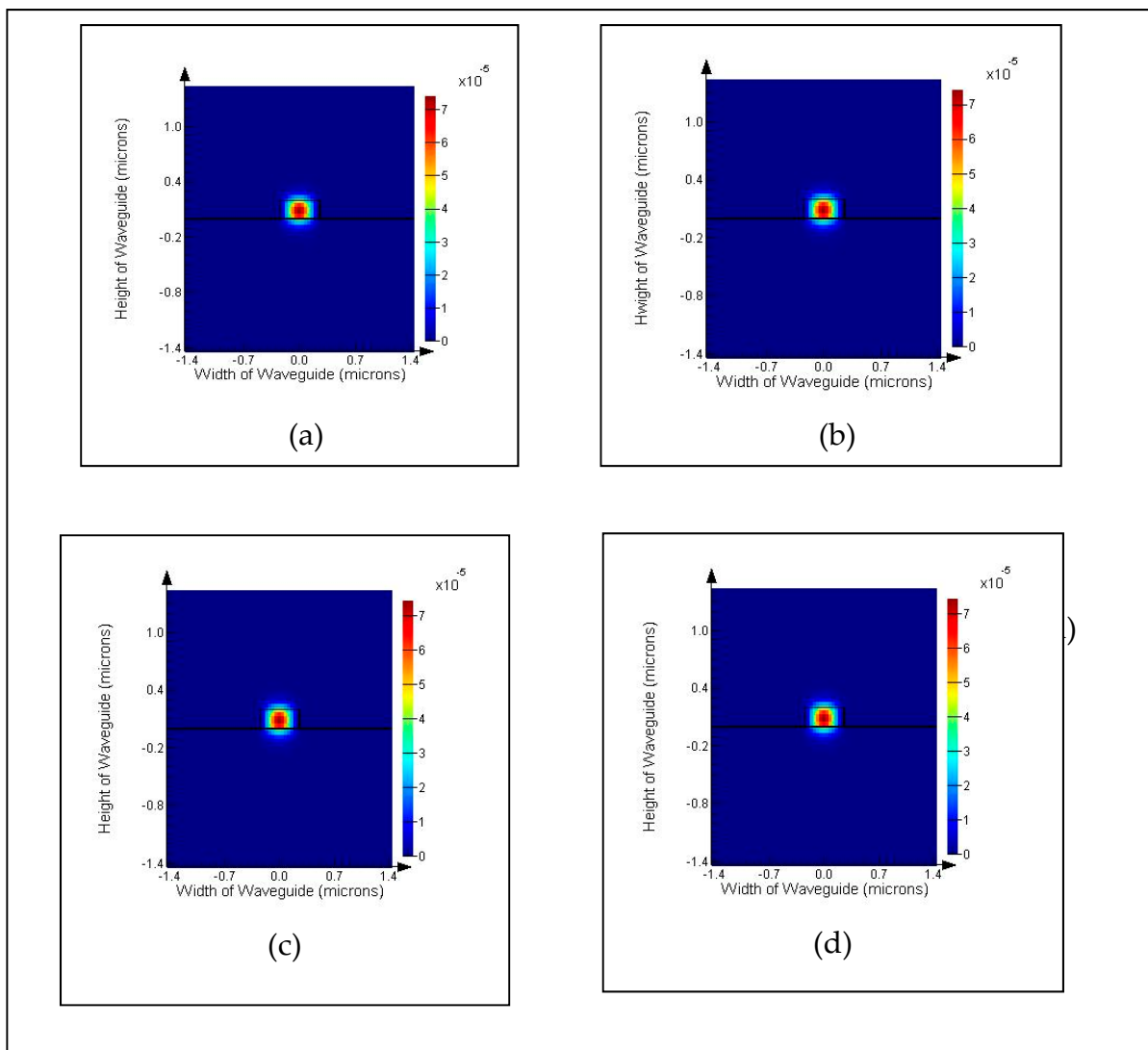
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256 Figure 7: Mode Confinement Plots: TE₀ mode confinement in a SOI waveguide at (a) 1500nm (b)
 257 1530nm (c) 1550nm (d) 1560nm

258 Figure 9 and 10 shows the effective index and loss in SOI waveguide for a wavelength range of
 259 1550nm to 1600nm. Table 3 gives the effective index, loss in dB/cm, percentage of TE/TM fraction for

260 the wavelengths 1550nm, 1530nm, 1550nm and 1600nm. Light and fluidic interaction is analyzed by
 261 considering fluidic region index as 1.334 (this approximately is refractive index of blood). The
 262 fluidic gap distance is designed is section 2 for 1.5 μ m. The input waveguide is excited by a laser
 263 source of 1550nm wavelength with 10dBm power level. The laser input power is coupled into the
 264 input waveguide the guided modes propagates through it and interacts with fluidic sample.
 265 Reflection of light takes place at the boundary between silicon core and fluidic sample. As a result
 266 the change in effective index occurs and the speed at which light propagates in the fluidic sample.
 267 This also results in variation of optical power intensity in the sensing region. Most of the light
 268 intensity is lost in the sensing region due to following optical phenomenons.

- 269 • Reflections of light into the substrate: It occurs due to low refractive index of fluidic sample
 270 (1.334) compared to substrate index (1.55).
 271 • Absorption of light: It occurs due to the nature micro samples present in the fluidic sample.
 272 Absorption co-efficient and power intensity are related by Beers-Lambertz law [19].

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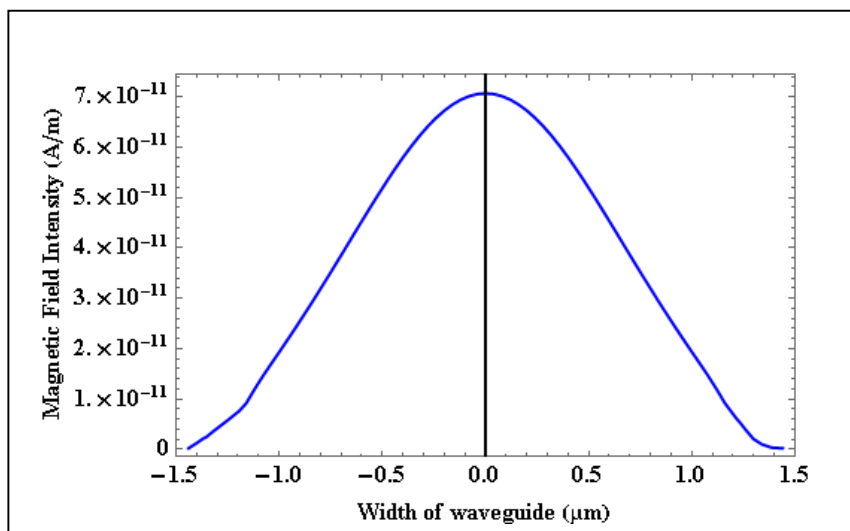
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Figure 8: Magnetic field intensity as a function of width of waveguide

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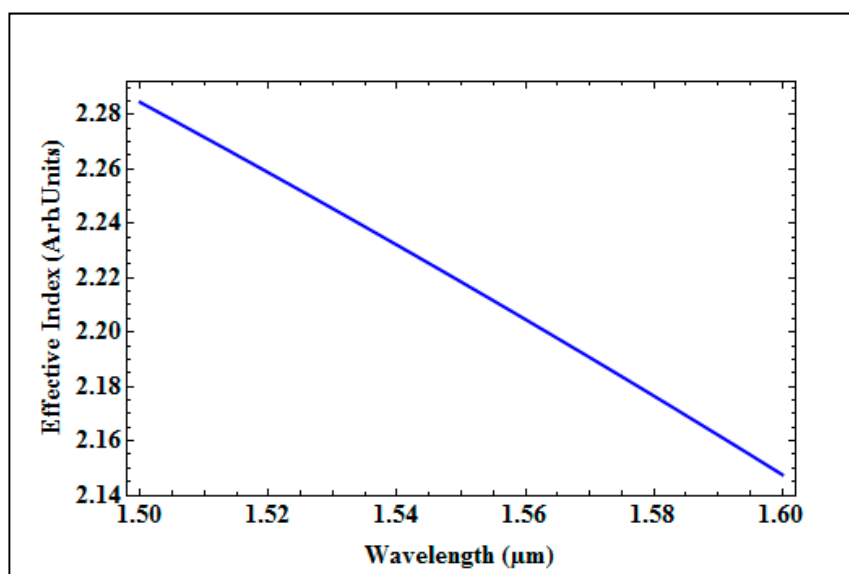
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Figure 9: Effective Index as a function of wavelength

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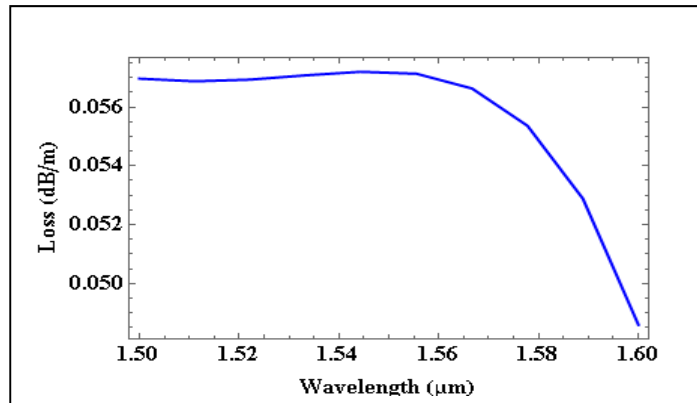
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Figure 10: Loss in waveguide as a function of wavelength

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Table 3: SOI Waveguide Parameter

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Wavelength in nm	Effective Index	Loss in dB/cm	%(TE/TM) Fraction
1500	2.3619	0.000569	73.96/81.6
1530	2.322	0.00057	72.97/81.43
1550	2.2963	0.0005719	72.32/81.33
1600	2.230	0.00048597	70.75/81.1

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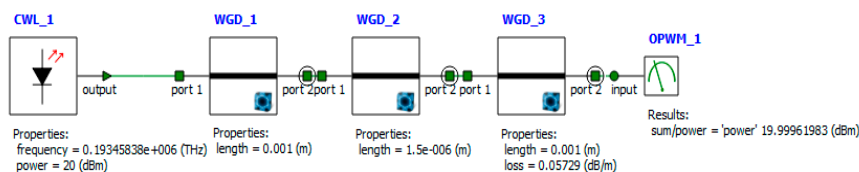
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The entire Lab-on-a-Chip structure as described in schematic representation of figure 1 and been simulated for optical mode propagation using 1550 nm source is shown in Figure 11. The optical power measurement analysis is carried out by considering input waveguide, output waveguide as mode waveguides with effective index 2.2963 and micro fluidic channel region as modal waveguide with effective index 1.383. The length of input and output waveguides is selected as 1mm and gap distance (fluidic channel width) is 1.5 μ m. The laser source wavelength is selected at 1550nm with a power level of 20dBm (1mW). The optical power of 19.999619 dBm is measured at the end of output waveguide using optical power meter. It indicates there is significant level of optical power coupling from input waveguide to output waveguide through the fluidic gap region. The optimum design parameters of the proposed sensor are listed in table 4.

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Figure 11: Optical power measurement using Interconnect

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Table 4: Design parameters of opto-fluidic sensor

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Parameter	Value
wavelength	1550nm
Height of input/output waveguide	250nm
Width of input /output waveguide	500nm
Width of fluidic channel	1.5 μ m
Length of input/output waveguide	1mm
Cross section of fluidic chambers	7.5 μ m \times 15 μ m

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327 5. Conclusions

328 In this work modeling and analysis of integrated waveguides, and micro-fluidic channel for
329 opto-fluidic lab-on-chip sensor application has been presented. The flow rate analysis between two
330 fluidic chambers connected by a narrow micro fluidic channel which is in a plane perpendicular to
331 integrated optical SOI waveguides is presented. The narrow fluidic channel sandwiched between
332 two single SOI waveguides acts as a sensing region. A continuous flow of fluidic sample in the
333 narrow micro fluidic channel is achieved by maintaining pressure of 1 Pascal at the centroid of the
334 fluid channel geometry. The sensor is designed for single mode operation, which, is achieved at 1550
335 nm for waveguide dimensions of 250 nm (height) and 500 nm (width). The effective refractive index
336 was found out to be 2.2963 with a negligible loss of 0.0005719dB/cm. It is observed that, when the
337 input waveguide is excited by a laser source with 20dBm power at 1550nm, a power level of
338 19.999dBm is measured at the end of output waveguide. The power measured from output
339 waveguide gives the qualitative measurement of optical properties and nature of the micro particles
340 present in the fluidic sample. This micro structure fluidic channel with integrated laser and detector
341 can be used for Bio-sensing applications.

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345 Author Contributions: "Venkatesha M, Chaya B M and Narayan K conceived and designed the experiments;
346 Venkatesha M performed the experiments; Venkatesha M, Narayan K, Chaya B M and Pattnaik P K analyzed
347 the data; Narayan K contributed analysis tools; Venkatesha M and Narayan K wrote the paper."

348 **Conflicts of Interest:** The authors declare no conflicts of interest.

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